

Title: SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF

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Atty Docket No.: 402769

Leydig, Voit & Mayer

202-737-6770

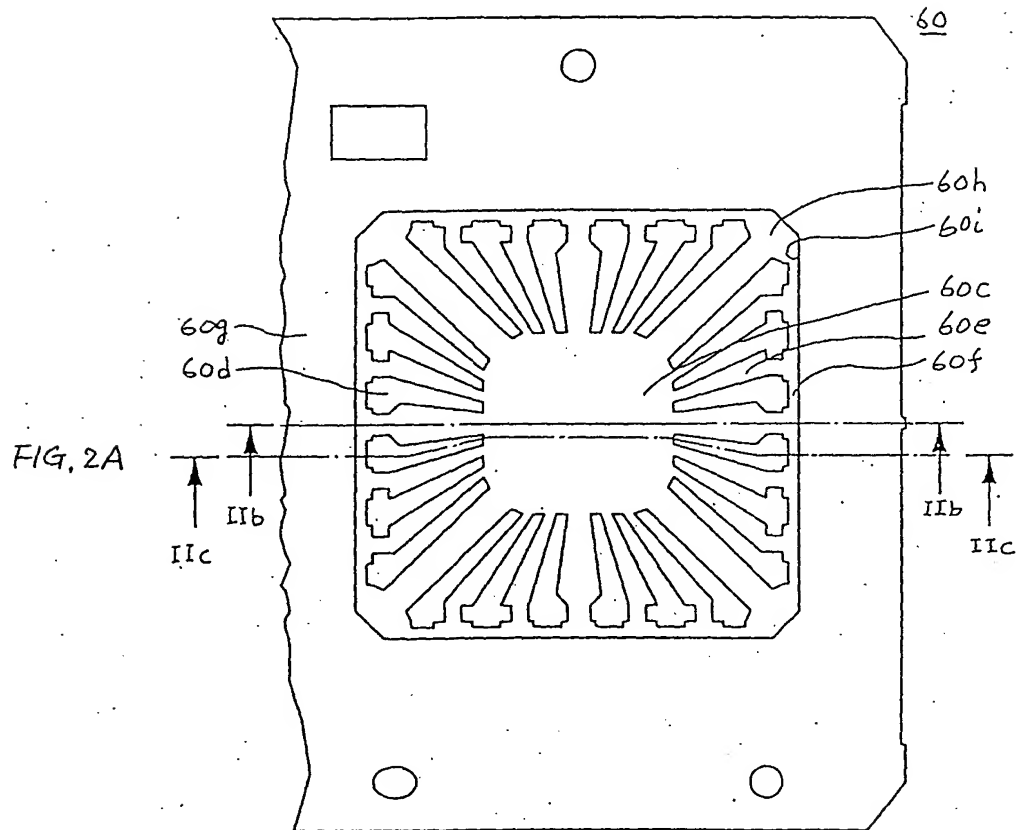


FIG. 2B

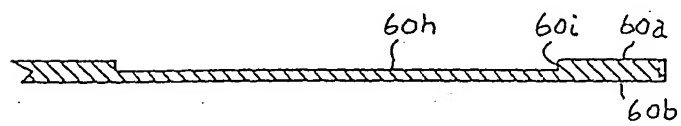


FIG. 2C

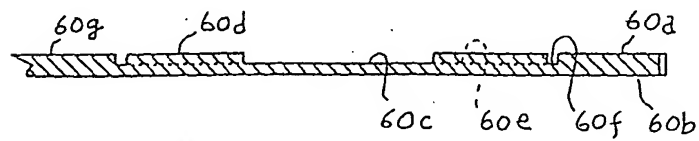


FIG. 3A

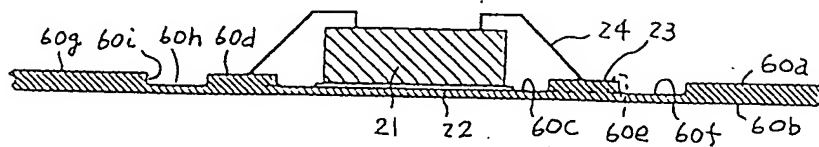


FIG. 3B

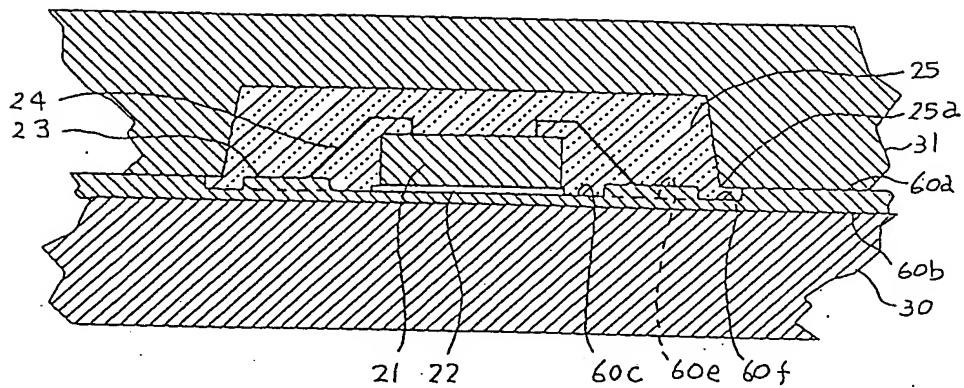


FIG. 3C

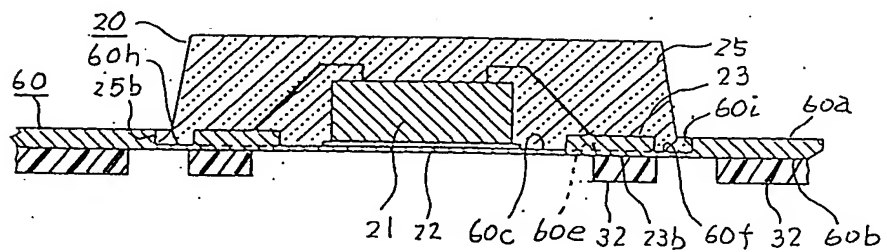


FIG. 3D

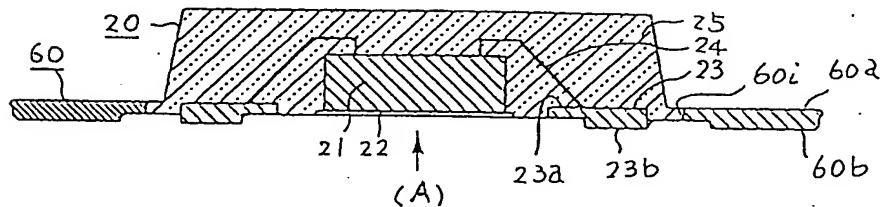
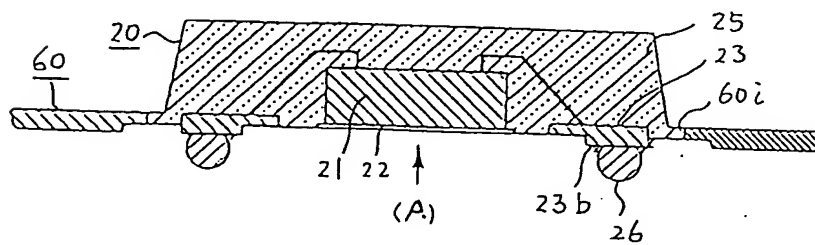
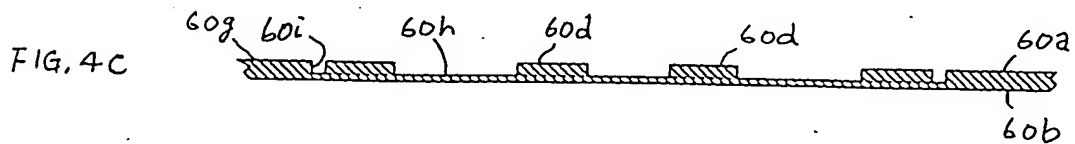
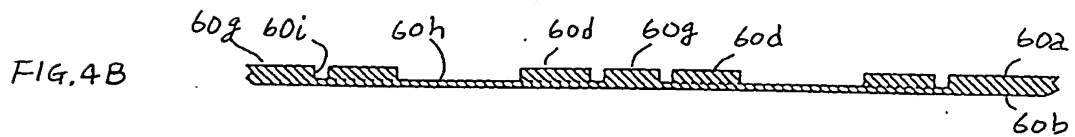
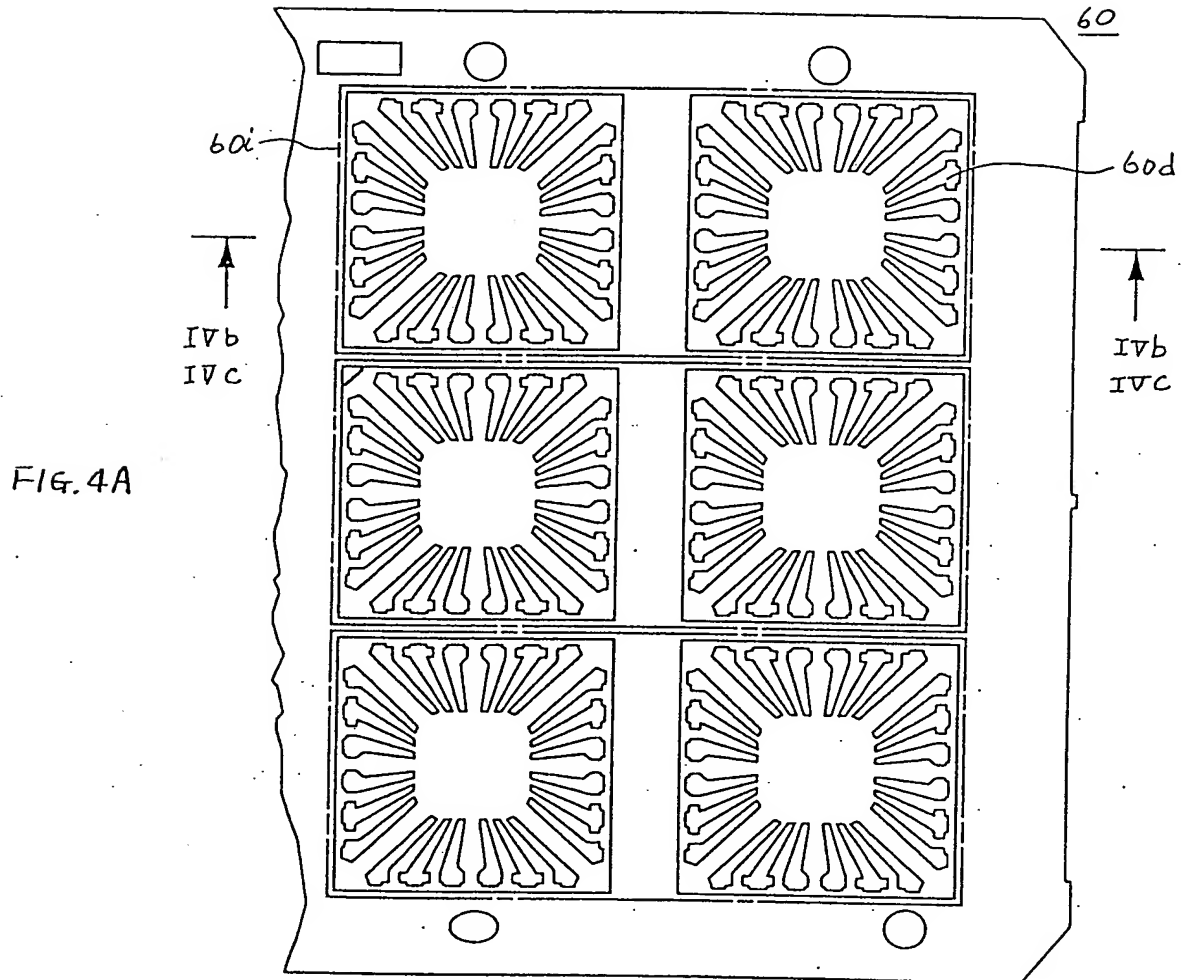
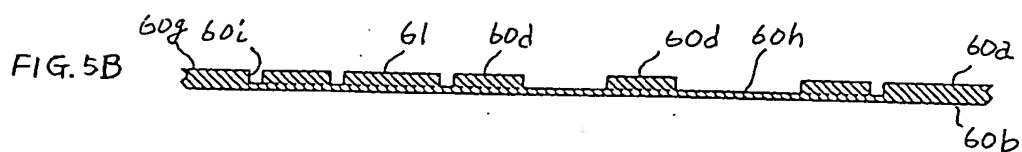
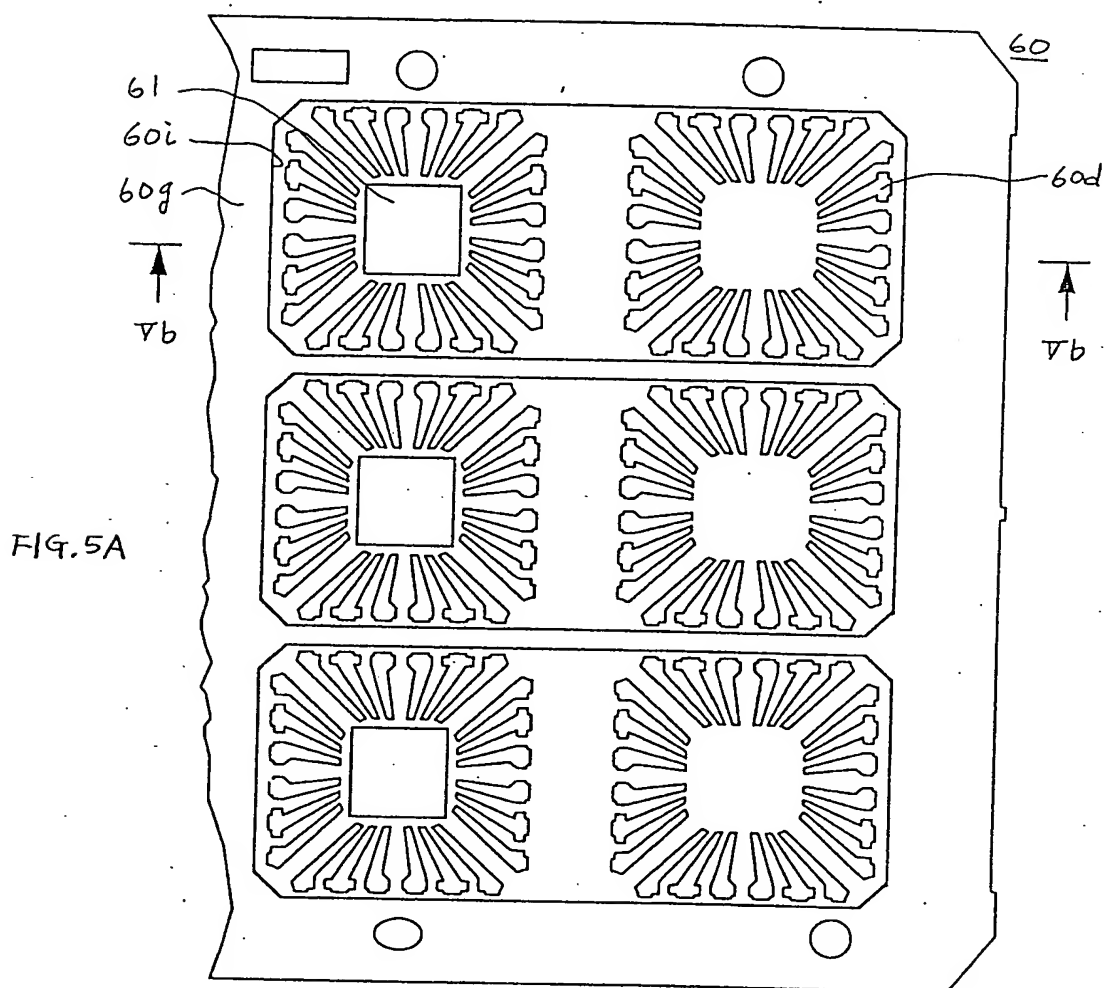
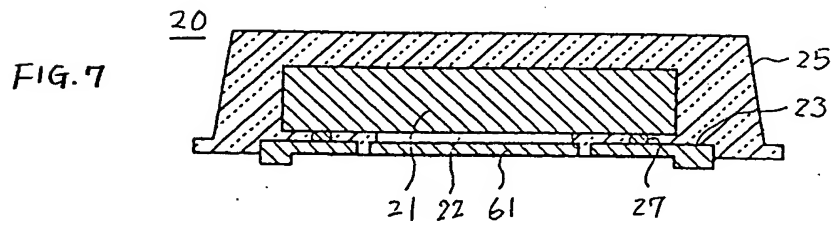
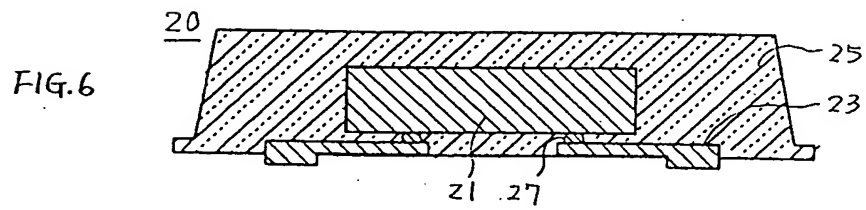


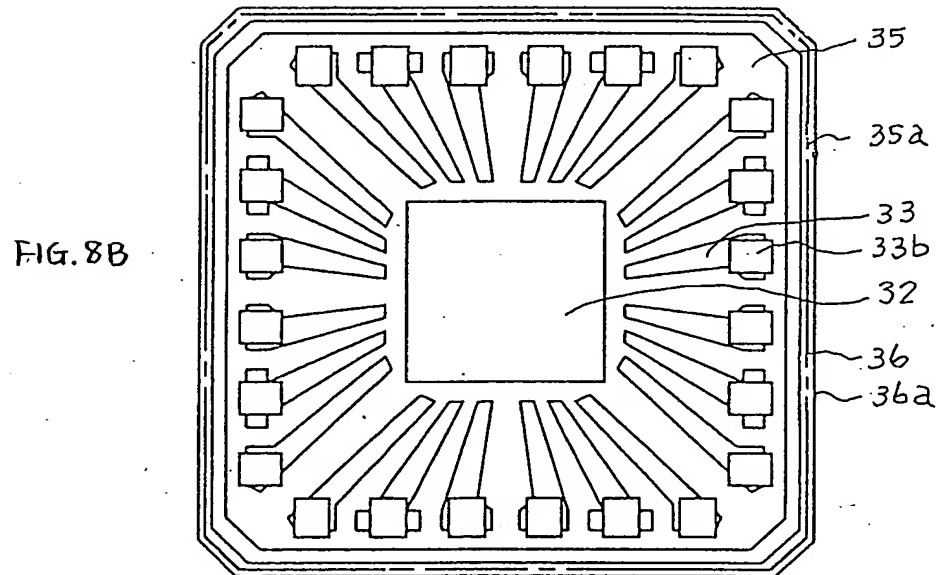
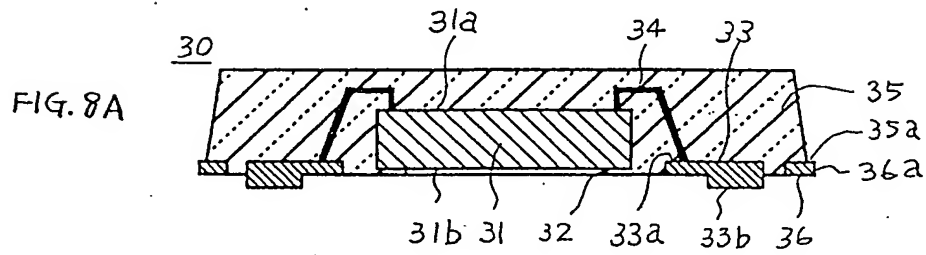
FIG. 3E

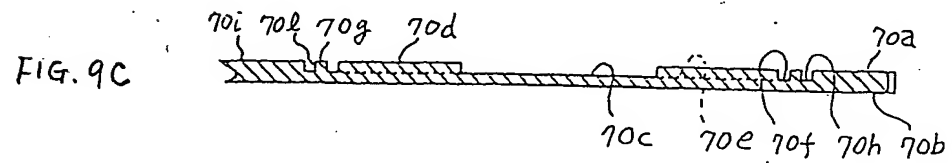
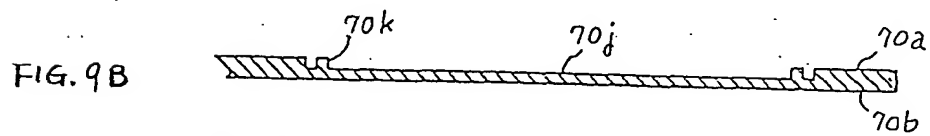
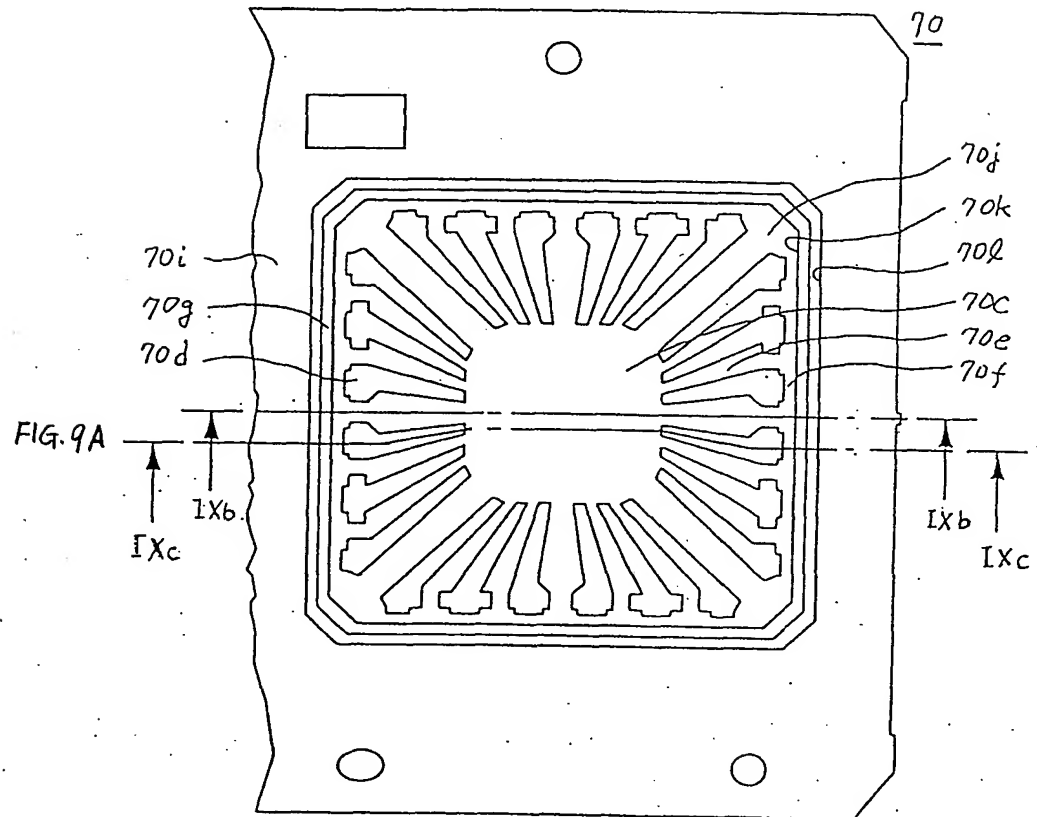














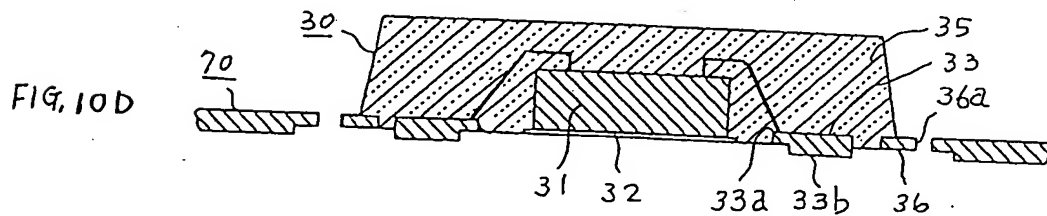
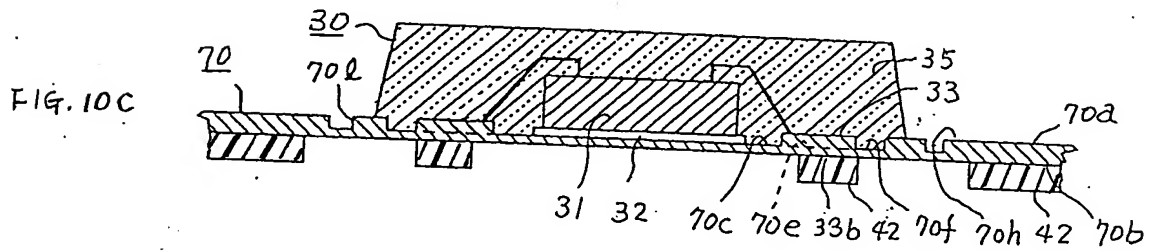
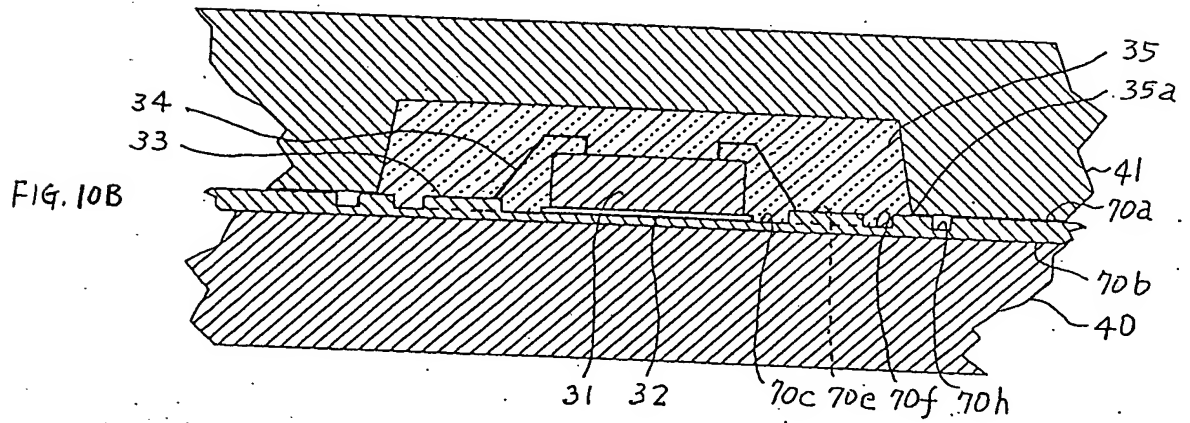
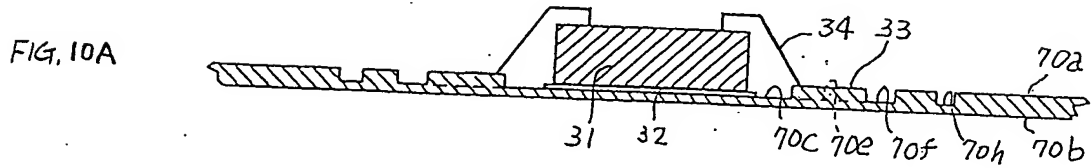


FIG. 11A

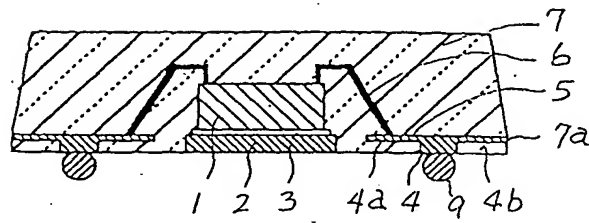
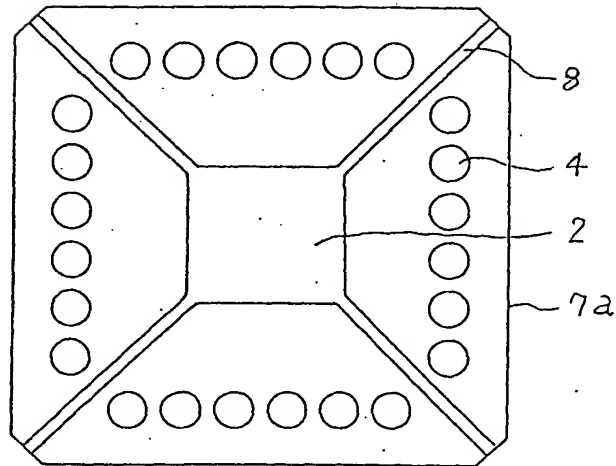


FIG. 11B



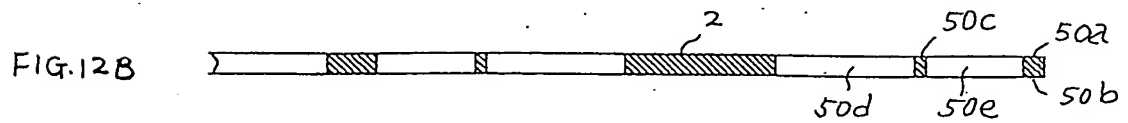
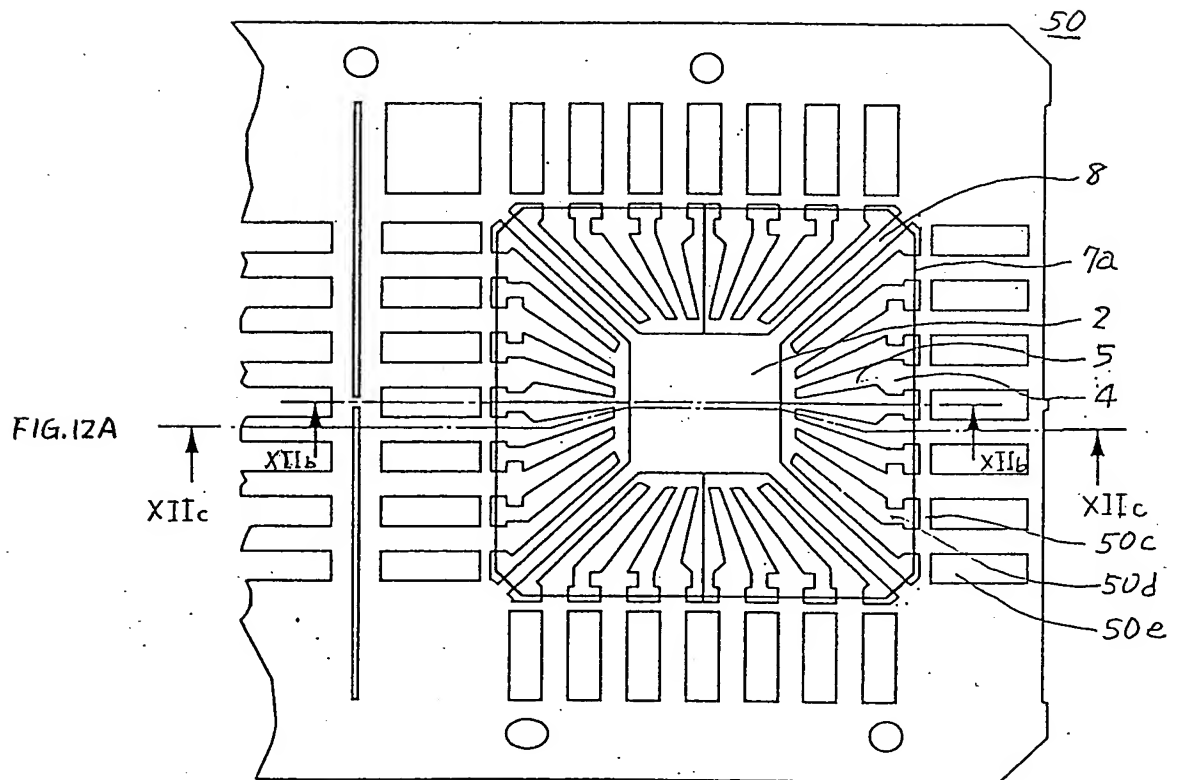


FIG. 13A



FIG. 13B

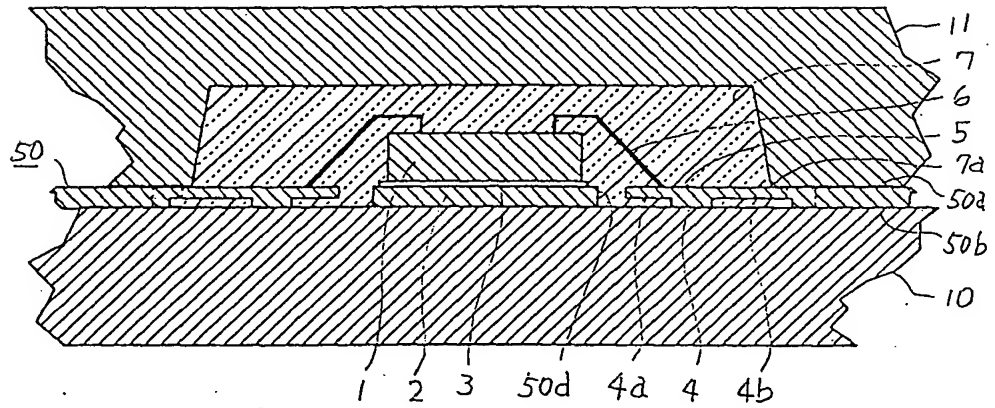


FIG. 13C

